### Ultra Low Power CMOS Technology

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Abstract - This paper discusses the motivation, opportunities, and problems associated with implementing digital logic at very low voltages, including the challenge of making use of the available real estate in 3D multichip modules, energy requirements of very large neural networks, energy optimization metrics and their impact on system design, modeling problems, circuit design constraints, possible fabrication process modifications to improve performance, and barriers to practical implementation.

### **1** Introduction

As technology continues to scale into the submicron regime, massively parallel architectures are increasingly being constrained by power considerations. Minimizing the energy per operation throughout the system is assuming increasing importance. We are investigating "Ultra Low Power CMOS" to reduce the energy per operation in massively parallel signal processors, microsatellites, and large scale neural networks. We are investigating operating with supply and threshold voltages of a few hundred millivolts to reduce energy per operation by a more than 100 times.

In this paper, we show that minimum energy per operation is achieved in the subthreshold regime, and that the optimum performance is obtained when  $Vdd = V_t$  and  $Gnd = V_t - Vdd$ . We also show that minimum energy  $\times$  time occurs when  $Vdd = 3V_t$ . We show that  $V_t$  should be chosen such that  $I_{on}/I_{off} = ld/a$ , where ld is the logic depth and ais the activity ratio, the fraction of gates which are switching at any given time. We also show that ld = 11 minimizes energy in a 32x32 bit parallel multiplier.

### 2 Motivation

The application domains we are targeting include wideband spectrometers requiring 10<sup>12</sup> operations per second, microsatellites with 100mW power budgets, large scale neural networks requiring 10<sup>15</sup> connections per second and 1fJ per connection, and small, massively parallel digital signal coprocessors.

As an example, a single SBus slot in a Sun SPARC station occupies about 200 cm<sup>3</sup>, can accommodate over  $2000 \text{ cm}^2$  of active silicon using 3D stacked multichip module technology, and has a power budget of 10W (see Fig 1). An architecture with a power density of  $2W/\text{cm}^2$  and 40 MIPS per chip, typical of modern microprocessors, would dissipate 4KW



Figure 1: 3D MCM in an SBus slot: 2000 cm<sup>2</sup>, 10W max. Vdd = 0.7V permits 10 GIPS.

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if tiled over the available area and achieve 80 billion operations per second. Only 5 cm<sup>2</sup> of silicon can be used at 10W, yielding 200 MIPS. If the supply voltage is lowered to 700mV, each chip would dissipate 5mW, and the entire 2000cm<sup>2</sup> could be used to achieve 10 billion operations per second at 10W.

### 3 Background

Low voltage digital logic is not new. Richard Swanson described a 100mV CMOS ring oscillator in [6]. Eric Vittoz discussed subthreshold design techniques used in the digital watch industry in [4]. Carver Mead described a variety of subthreshold analog circuits for neural networks in [1]. We believe that low voltage circuits can be used effectively for massively parallel computation in power constrained environments, and that lowering the voltage in submicron technologies has the added benefit of maintaining manageable signal frequencies at the system level.

### 4 Transistor Current

The following equations [6,7] describe drain current as a function of gate voltage, as shown in Fig 2.



Figure 2: Transistor current vs voltage. Current in exponential with voltage below  $V_t$ , and quadratic above  $V_t$ .



Figure 3: Model discontinuity at  $V_{gs} = V_t$ . The subthreshold model says  $I_{ds} = knV_T^2$ . The saturation model says  $I_{ds} = \frac{k}{2}(V_{gs} - V_t)^2 = 0$ . In the figure  $V_t = 200$  mV.

subthreshold:  $V_{gs} < V_t$ ;  $I_0 = knV_T^2$  $I_{ds} = I_0 e^{\frac{V_{gs} - V_t}{nV_T}} (1 - e^{-\frac{V_{ds}}{V_T}})$ 

saturation:  $V_t$ 

 $\begin{array}{l} V_t < V_{g\mathfrak{s}} < V_{d\mathfrak{s}} + V_t \\ I_{d\mathfrak{s}} = \frac{k}{2} (V_{g\mathfrak{s}} - V_t)^2 \end{array}$ 

linear:

$$\begin{aligned} V_{ds} + V_t < V_{gs} \\ I_{ds} &= \frac{k}{2} (2(V_{gs} - V_t)V_{ds} - V_{ds}^2) \end{aligned}$$

where  $V_{gs}$  is the gate-source voltage,  $V_t$  is the threshold voltage,  $I_{ds}$  is the drain current, k is the transconductance in  $A/V^2$ , n is the gate coupling coefficient, usually around 0.7,  $V_T$  is the thermal voltage, 0.026V, and  $I_0$  is the current at  $V_{gs} = V_t$ .

Note the exponential dependence of current on voltage below  $V_t$ , and the quadratic dependence above  $V_t$ . These equations do a poor job of modeling behavior in the neighborhood of  $V_t$  (see Fig 3).



Figure 4: Performance vs voltage for different values of  $V_t$ .

Performance can be approximated when the supply voltage is over threshold by

$$f = I/Q = rac{k}{2}(V - V_t)^2/(CV)$$

where f is the clock frequency, k is transconductance, and C is the capacitance being switched.

### 5 Optimum Logic Depth



Figure 5: Optimum logic depth of a  $32 \times 32$  bit tree multiplier. For a given ld, the supply voltage is lowered to match the unpiped throughput. Minimum power consumption occurs at ld = 11. Latch energy increases as ld decreases, eventually exceeding logic energy, which decreases as ld decreases.



Figure 6: Relative area vs logic depth in a  $32 \times 32$  bit multiplier. The area penalty at ld = 11 is 37%.

We found the optimum logic depth in a  $32 \times 32$  bit tree multiplier by reducing the supply voltage to keep the throughput constant (see Fig 5). We also found the area penalty using this approach (see Fig. 6). ld = 11 is close to the propagation delay through a 4:2 adder [2].

### 6 Minimum Energy

The current available to switch a node is the difference between the current of the ON device and the leakage current of the OFF device. In standard CMOS,  $V_t$  is so high that  $I_{off}$  can be ignored, but in low voltage applications it can be an appreciable fraction of  $I_{on}$ :

$$t_{pd} = \frac{Q}{I} = \frac{C_g V}{I} = \frac{C_g V}{I_{on} - I_{off}}$$

$$E_{dc} = I_{off} V l_d t_{pd} = C_g V^2 \frac{l_d}{\frac{I_{on}}{I_{off}} - 1}$$

$$E_{ac} = \frac{1}{2} a C_g V^2$$

$$E = E_{ac} + E_{dc} = \frac{1}{2} C_g V^2 (a + \frac{2l_d}{\frac{I_{on}}{I_{off}} - 1})$$

E is minimum when  $I_{on}/I_{off}$  is maximum. Referring to Fig 2,  $I_{on}/I_{off}$  is maximum and constant in the subthreshold region.

In the subthreshold region, if  $V_{ds} = V = V_{hi} - V_{lo}$ , then  $I_{on}/I_{off} = e^{(V_{hi}-V_{lo})/(nV_T)} = e^{V/(nV_T)}$ , so *E* depends only on  $V = V_{hi} - V_{lo}$ . Therefore, for a given Vdd, energy is constant in the subthreshold region. For maximum performance at minimum energy, set  $V_{hi} = V_t$  and  $V_{lo} = V_t - V_{dd}$ .

DC energy rises exponentially as Vdd decreases. AC energy rises quadratically as Vdd increases. For optimum  $V_t$ ,

$$P_{ac} = aCV^2 f$$
  
 $P_{dc} = I_{off}V$   
 $I_{on} = ldCVf$ 

If  $P_{ac} = P_{dc}$  and Vdd =  $V_t$ , then

$$I_{on}/I_{off} = ld/a = e^{V_t/(nV_T)}$$
$$V_t = nV_T \ln(I_{on}/I_{off})$$

Figs 7 and 8 show energy vs Vdd. Table 1 lists the voltages and energies at the global minima.



Figure 7: Energy vs supply voltage for a = 0.10, ld = 10 in  $2\mu$  CMOS



Figure 8: Energy vs supply voltage for a = 0.01, ld = 40 in  $2\mu$  CMOS

# 7 Minimum Energy x Time



Figure 9: 1/(energy × time) vs Vdd and  $V_t$ .  $Et_{\min}$  occurs at  $3V_t$ .

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The minimum energy solution is quite slow. Performance should improve dramatically in deep submicron and with low voltage process optimizations. An alternative approach is to minimize energy  $\times$  time. If we assume transistors operate mostly in saturation, then

$$Et = V^2 Q/I = V^3/(V - V_t)^2$$
$$Et_{min} = \frac{9}{4}V \text{ at } V = 3V_t$$

Fig 9 shows a maximum at  $3V_t$  which grows much more pronounced at low voltage.

### 8 Circuit Design Constraints

A number of interesting circuit design constraints appear when leakage currents are large, and when the dependence of current on voltage is exponential. Three constraints we have observed to date:

- Dynamic circuits are difficult to manage. A minimum size transistor will have a leakage current of about 1nA at  $V_t = 160$  mV. A dynamic storage node with 100 fF of capacitance will hold 50 fC of charge at Vdd=0.5V. A change of 100 mV requires movement of 10 fC. 10 fC/1nA = 10 usec.
- Exponential dependence of current on voltage makes pass transistor logic difficult to use. nfets cannot pass ones and pfets cannot pas zeros. In particular, using nfets as access transistors for static latches does not work.

parameter	negative	positive
reduce $X_j$	increase $R_S, R_D$	decrease
		cjsw,cgso,cgdo
reduce $T_{ox}$	decrease $V_{gs}max$	increase k
	(gate-src breakdown)	
	increase $C_{ox}$	decrease n
	(increase energy)	
reduce $N_B$	decrease $V_{ds}max$	increase uo
	(punchthrough)	decrease
		cj, cjsw, n
reduce $N_G$	increase $R_G$	decrease $V_t$
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reduce $N_D$	increase $\pi_S, \pi_D$	decrease
		<i>cj,cjsw</i>

Table 2: Process optimization opportunities.

• Fully static logic appears to work well. Transmission gate latches work nicely. SRAM seems to work well, since one of the bitlines will be pulling down on a write.

# 9 Process Optimization

The opportunity exists to improve performance by optimizing fabrication processes for low voltage operation. Carrier mobility degrades significantly in submicron processes as channel doping is increased to prevent punchthrough in the presence of strong electric fields. Reduced voltage operation results in weaker fields, permitting lower channel doping which results in higher carrier mobility and increased transconductance.

Reduced voltage operation also permits lower diffusion doping, since higher diffusion resistance will not impact circuit performance due to reduced transistor drain current. This reduces diffusion capacitance to a negligible fraction of gate capacitance. The only drawback of reducing diffusion doping is that lateral diffusion is reduced, increasing the effective channel length. This is partially offset by the reduced Miller effect since the gatedrain overlap capacitance is reduced. Table 2 summarizes the impact of various process modifications on energy and performance.

While a lower bound of 60 mV/decade is achievable at room temperature  $(dV = nV_T ln(10) \text{ with } n = 1)$ , dV is more typically 80 mV/decade in  $2\mu \text{ CMOS}$  and 90 mV/decade in  $0.8\mu \text{ CMOS}$ .  $T_{ox}/d_0$  can be reduced by reducing  $N_B$ , since  $d_0 = \sqrt{2\epsilon_{si}\phi_{ss}/(qN_B)}$ , where

 $\phi_{ss} = V_T ln(N_B/n_i)$  and  $n_i = \sqrt{1.5T^3 e^{-1.15/V_T}} \times 10^{16}$  [5].

Low gate, drain, and threshold voltages permit all doping concentrations to be reduced, once again due to lower electric field strength. This has two benefits for low voltage operation:

- 1. *n* is reduced, decreasing the subthreshold slope and thus reducing the supply voltage (and therefore energy per operation) necessary to achieve the desired on/off current ratio.
- 2. source/drain capacitances are reduced, further reducing energy per operation.

## **10 Barriers to Practical Implementation**

A number of practical considerations place a lower bound on supply voltage. These are: external interfacing, controlling device thresholds, maintaining adequate noise margins, power supply design, power consumption of OFF devices, and circuit speed. Multichip module packaging provides the opportunity to isolate low-voltage subsystems from other system components. Limits to low voltage operation may be determined to a large extent by the power dissipation in level-shifting interface circuits. Device thresholds have been observed to vary with transistor geometry and even location on a chip [3].

A 10 watt power supply will have to deliver 20 amps at Vdd = 500 mV.

### 11 CIS Testchip

In the BiCMOS process at Stanford's Center for Integrated Systems, pfet gates are doped p+ and nfet gates are doped n+. This means that if the channel implant is excluded, both devices have thresholds close to zero volts.  $V_t$  can then be adjusted by adjusting the substrate bias voltage. We have implemented a test chip which contains a number of simple circuit structures (see Fig 10), and will hopefully have some results in time for the conference. The chip has the following characteristics:

- Pfet gates doped p + have  $V_t \approx 0V$
- Independent substrate and well biases
- self-testing convolutional coder
- ring oscillator
- VCO
- single nfet, pfet, nand, latch

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Figure 10: Ultra Low Power test chip. Separate bias voltages together with zero- $V_t$  pfets permit threshold adjustment.

# 12 Conclusions

Submicron CMOS, together with 3D stacked multichip modules, and massively parallel machines demand new approaches to power dissipation. We are in the very early stages of investigating reducing energy by reducing supply and thresholds voltages. We are hopeful that low voltage CMOS can find widespread use in performance driven, power constrained systems.

# 13 Acknowledgements

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